IAP16 Rec'd PCT/PTO 22 SEP 2006 10/593857

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXPRESS MAIL NO. EV809338217US

Applicant

: Nam Hun Kim

Application No. : N/A

Filed

: September 22, 2006

Title

: PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND

METHOD FOR ETCHING THE WAFER USING THE SAME

Grp./Div.

: N/A

Examiner

: N/A

Docket No.

: 58409/N305

INFORMATION DISCLOSURE STATEMENT 37 CFR § 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Post Office Box 7068 Pasadena, CA 91109-7068 September 22, 2006

Commissioner:

In compliance with the duty of disclosure under 37 CFR §§ 1.56, 1.97 and 1.98, and in accordance with the provisions in the Manual of Patent Examining Procedure §§ 609 and 707.05(b), enclosed is FORM PTO/SB/08A/B listing the references that are known to applicant. Copies of each of the listed Foreign Patent Documents and Other Documents are enclosed. This filing is timely because it is made during one of the periods described in 37 CFR § 1.97(b).

It is respectfully requested that the listed references be considered in the examination of this application and identified on the list of references cited on the patent issuing for this application. Applicant also requests that an initialed copy of FORM PTO/SB/08A/B be entered in the application file and returned to applicant with the next communication from the Office in accordance with MPEP § 609.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

an Rueut D. Bruce Prout

Reg. No. 20,958 626/795-9900

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Enclosures: Form PTO/SB/08A/B, w/references

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FORM PTO/SB/08A/B (10-01) Substitute for PTO-1449A/B	Attorney Docket Number	58409/N305
INFORMATION DISCLOSURE	Application Number	N/A
	Filing Date	September 22, 2006
STATEMENT BY APPLICANT	Applicant(s)	Nam Hun Kim
(use as many sheets as necessary)	Group Art Unit	N/A
	Examiner Name	N/A

U.S. PATENT DOCUMENTS				
EXAMINER INITIALS	Cite No.1	DOCUMENT NUMBER Number - Kind Code ² (If Known)	Publication Date MM-DD-YYYY	Name of Patentee
		5,690,781	11-25-1997	Yoshida et al.
		6,534,007 B1	03-18-2003	Blonigan et al.

FOREIGN PATENT DOCUMENTS				
Cite No. ¹	FOREIGN PATENT DOCUMENT Country Code ³ - Number ⁴ - Kind Code ⁵ (If Known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	(*)
	JP 8-88190	04-02-1996	Yoshida et al.	Patent Abstracts of Japan and Corresponding U.S. 5690781 Above
	JP 2002-110642	04-12-2002	Yasuda	Patent Abstracts of Japan
	JP 2003-24773	01-28-2003	Takagi et al.	Patent Abstracts of Japan
	KR 20-0177585	04-15-2000	Lee	Abstract
	KR 10-2002-0054479	07-08-06	Lee et al.	Korean Patent Abstracts
	WO 99/06610	02-11-1999	Blonigan et al.	Corresponding U.S. 6534007 Above
	_	Cite No.¹ FOREIGN PATENT DOCUMENT Country Code³ - Number⁴ - Kind Code⁵ (If Known) JP 8-88190 JP 2002-110642 JP 2003-24773 KR 20-0177585 KR 10-2002-0054479	Cite No.1 FOREIGN PATENT DOCUMENT Country Code3 - Number4 - Kind Code5 (If Known) Publication Date MM-DD-YYYY JP 8-88190 04-02-1996 JP 2002-110642 04-12-2002 JP 2003-24773 01-28-2003 KR 20-0177585 04-15-2000 KR 10-2002-0054479 07-08-06	Cite No.1 FOREIGN PATENT DOCUMENT Country Code³ - Number⁴ - Kind Code⁵ (If Known) Publication Date MM-DD-YYYY Name of Patentee or Applicant of Cited Document JP 8-88190 04-02-1996 Yoshida et al. JP 2002-110642 04-12-2002 Yasuda JP 2003-24773 01-28-2003 Takagi et al. KR 20-0177585 04-15-2000 Lee KR 10-2002-0054479 07-08-06 Lee et al.

OTHER DOCUMENTS		
Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
	International Search Report, dated 07-11-2005, corresponding to PCT/KR2005/000860	
	Patent Abstracts of Japan, Publication 08-088190, Published 04-02-1996, in the name of Yoshida et al.	
	Patent Abstracts of Japan, Publication 2002-110642, Published 04-12-2002, in the name of Yasuda	
	Patent Abstracts of Japan, Publication 2003-024773, Published 01-28-2003, in the name of Takagi et al.	
	Korean Patent Abstracts, Publication 1020020054479 A, Published 07-08-2002, in the name of Lee et al.	

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EXAMINER SIGNATURE	DAT CON	NTE ONSIDERED	
EVAMINED: Initial if reference considered whether or not citation is in conformance with MDED 600. Draw line through citation if not in			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.pto.gov or MPEP 901.4. ³Enter Office that issued the document, by the two-letter code (WIPO standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English Language Translation is attached.